Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S2	366	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/20 06:44
S3	339	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040312")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/21 07:39
S4	339	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040312")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:06
S5	186	S4 and ((conductive) same (material))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/21 07:42
S6	186	S4 and ((conductive) same (material)) and (deposit$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/21 07:49
S7	339	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040312")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/21 12:42
S8	173	S7 and ((conductive) same (material)) and (deposit$4) and ((aluminum) or (Al))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 15:08
S9	0	("9590322").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/21 13:27
S10	1	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040312") and (dual-frequency)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/21 13:52
S11	2	(vandroux-laurent.in.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 08:16

S12	3	(monchoix-herve.in.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 08:16
S13	104	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040312") and (hydrocarbon)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 08:18
S14	103	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040311") and (hydrocarbon)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 15:08
S15	0	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040311") and (hydrocarbon) and (dual-frequency)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 09:09
S16	1	((amorphous) adj1 (carbon)) and (deposition) and (@ad<="20040311") and (hydrocarbon) and (dual-frequency)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 10:40
S18	0	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040311") and ((selctivity) near (amorphous) near ((conductive) or (metal)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:15
S19	0	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040311") and ((selctiv$5) same (amorphous) same ((conductive) or (metal)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:09
S20	0	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040311") and (selctiv$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:10
S22	0	((amorphous) adj1 (carbon)) and (etch) and (@ad<="20040311") and (selctiv$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:14
S23	919	((amorphous) adj1 (carbon)) and (etch) and (@ad<="20040311") and (selectiv$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:16
S24	0	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040311") and ((selectivity) near (amorphous) near ((conductive) or (metal)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:15

S25	852	((amorphous) adj1 (carbon)) and (etch) and (@ad<="20040311") and (selectiv$5) and ((metal) or (conductive))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:17
S26	34	((amorphous) adj1 (carbon)) same (etch) same (selectiv$5) same ((metal) or (conductive)) and (@ad<="20040311")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 11:18
S27	339	((amorphous) adj1 (carbon)) and (deposition) and (hard) and (mask) and (etch) and (@ad<="20040312")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 15:11
S28	34	S27 and ((conductive) same (material)) and (deposit$4) and ((aluminum) or (Al)) and (((ARC) or (anti-reflective)) same ((silicon nitride) or (silicon carbide)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/22 15:15
S29	15	S27 and ((conductive) same (material)) and (deposit$4) and ((aluminum) or (Al)) and (((ARC) or (anti-reflective)) same (((silicon) adj1 (nitride)) or ((silicon) adj1 (carbide))))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/23 13:06